Application Serial No: New Application

Inv: Akira HOKAZONO, et al. Preliminary Amendment

Oblon Docket No: 239757US-2 DIV

DOCKET NO: 239757US-2 DIV

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

AKIRA HOKAZONO, ET AL. : EXAMINER:

SERIAL NO: NEW APPLICATION :

FILED: HEREWITH : GROUP ART UNIT:

FOR: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

**SAME** 

## PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.